

Response under 37 CFR 1.116 — Expedited Procedure
Examining Group

Attorney Docket No. 3481P009D

Patent**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re of Application of:

Joseph Wytman

Examiner: Mutschler, Brian L.

Application No.: 09/825,648

Art Group: 1753

Filing Date: April 4, 2001

For: METHOD OF PROCESSING WAFERS USING A
COMPLIANT WAFER CHUCK (AS AMENDED)

Mail Stop: AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AND RESPONSE TO FINAL OFFICE ACTION

Sir:

In response to the Office Action of August 20, 2003, please enter the following amendments. The amendments are believed to place the application in condition for allowance as further explained below.

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on

November 19, 2003

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